



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 16, 2026	
IGI Report Number	LG773667147
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	9.53 X 6.24 X 3.79 MM

GRADING RESULTS

Carat Weight	1.50 CARAT
Color Grade	D
Clarity Grade	VS 1

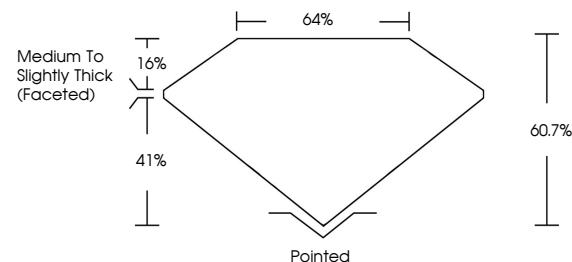
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG773667147

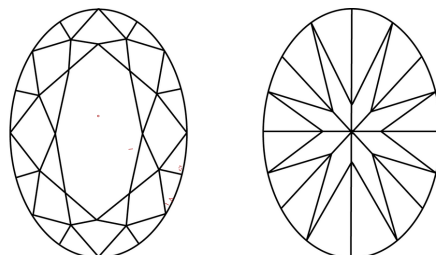
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG773667147
Report verification at iqi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

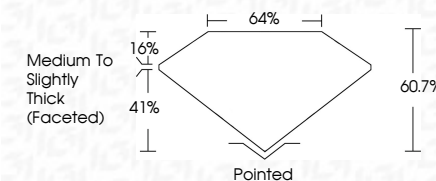
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www.igi.org

February 16, 2026	Lab Report No. LG773667147	1.50 CARAT
GI REPORT		D
VS 1	60.1%	VS 1
64%		64%
Medium to Slightly Thick (Faceted)		
Pointed		
EXCELLENT		
EXCELLENT		
NONE		
1691 LG773667147		

Comments:

The Laboratory Grown Diamond was
 analyzed for Chemical Vapor Deposition
 (CVD) growth process.
 type IIG